

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q76587

Kouji TAKAHASHI, et al.

Appln. No.: 10/619,181

Group Art Unit: 1731

Confirmation No.: 4972

Examiner: Anna L. KINNEY

Filed: July 15, 2003

For: GLASS SUBSTRATE FOR A MASK BLANK, METHOD OF PRODUCING A GLASS  
SUBSTRATE FOR A MASK BLANK, MASK BLANK, METHOD OF PRODUCING  
THE MASK BLANK, TRANSFER MASK, AND METHOD OF PRODUCING A  
TRANSFER MASK

NOTICE OF APPEAL

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant hereby appeals to the Board of Patent Appeals and Interferences from the final  
Office Action dated March 7, 2007.

The statutory fee of \$500 is being charged to Deposit Account No. 19-4880 via EFS  
Payment Screen. The USPTO is also directed and authorized to charge all required fees, except  
for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit  
any overpayments to said Deposit Account.

Respectfully submitted,

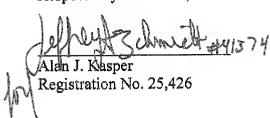
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WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: September 7, 2007

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